

BAR CODE LABEL



U.S. PATENT APPLICATION

SERIAL NUMBER

07/863,791

FILING DATE

04/06/92

CLASS

430

GROUP ART UNIT

1507

APPLICANT

JANG F. CHEN, SAN JOSE, CA; JAMES A. MATTHEWS, MILPITAS, CA.

CONTINUING DATA***
VERIFIED

FOREIGN/PCT APPLICATIONS***
VERIFIED

FOREIGN FILING LICENSE GRANTED 05/06/92

STATE OR
COUNTRY

CA

SHEETS
DRAWING

7

TOTAL
CLAIMS

23

INDEPENDENT
CLAIMS

3

FILING FEE
RECEIVED

\$1,010.00

ATTORNEY DOCKET NO.

57017.P025

ADDRESS

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN
12400 WILSHIRE BLVD., 7TH FL.
LOS ANGELES, CA 90025

TITLE


METHOD FOR IMPROVED LITHOGRAPHIC PATTERNING IN A SEMICONDUCTOR
FABRICATION PROCESS

This is to certify that annexed hereto is a true copy from the records of the United States
Patent and Trademark Office of the application as filed which is identified above.

By authority of the
COMMISSIONER OF PATENTS AND TRADEMARKS

Date

Certifying Officer

BAR CODE LABEL 		<h1 style="margin: 0;">U.S. PATENT APPLICATION</h1>			
SERIAL NUMBER 07/863,791	FILING DATE 04/06/92	CLASS 430	GROUP ART UNIT 1503		
<div style="display: flex; justify-content: space-between;"> <div style="writing-mode: vertical-rl; transform: rotate(180deg); font-weight: bold;">APPLICANT</div> <div> <p style="margin: 0;"> ¹⁻⁰⁰ <u>JANG F. CHEN, SAN JOSE, CA;</u> ²⁻⁰⁰ <u>JAMES A. MATTHEWS, MILPITAS, CA.</u> </p> <p style="margin: 0; margin-left: 100px;"> <u>CA</u> <u>CA</u> </p> </div> </div> <p style="margin-top: 20px;">**CONTINUING DATA*****</p> <p>VERIFIED</p> <p>_____</p> <p style="margin-top: 20px;">**FOREIGN/PCT APPLICATIONS*****</p> <p>VERIFIED</p> <p>_____</p> <p style="margin-top: 20px;">FOREIGN FILING LICENSE GRANTED 05/06/92</p>					
STATE OR COUNTRY CA	SHEETS DRAWING 7	TOTAL CLAIMS 23	INDEPENDENT CLAIMS 3	FILING FEE RECEIVED \$1,010.00	ATTORNEY DOCKET NO. 57017.P025
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<p style="margin: 0;">This is to certify that annexed hereto is a true copy from the records of the United States Patent and Trademark Office of the application which is identified above.</p> <p style="margin: 0;">By authority of the COMMISSIONER OF PATENTS AND TRADEMARKS</p> <div style="display: flex; justify-content: space-between; margin-top: 20px;"> <div>Date</div> <div>Certifying Officer</div> </div>					